



520.41003X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Y. KIMURA et al
Serial No.: 10/019,407
Filed: March 25, 2002
For: POLYCRYSTALLINE SEMICONDUCTOR THIN FILM
SUBSTRATE, MANUFACTURING METHOD OF THE SAME,
SEMICONDUCTOR DEVICE AND ELECTRONIC DEVICE
Group: 2813
Examiner: L. SCHILLINGER

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
POB 1450
Alexandria, VA 22313-1450


May 25, 2005

Sir:

In reply to the Restriction Requirement, dated April 14, 2005, the period of response for which extension of time is requested in the attached Petition for Extension of Time, applicants hereby elect Group I, Species 2 claims 3-4, drawn to a semiconductor device formed by a plurality of laser steps such that the closed crystal grains is 6, without traverse.

To the extent necessary, applicants petition for an extension of time under 37 CFR §1.136. Please charge any shortage in the fees due in connection with the filing of this paper, to the Deposit Account of Antonelli, Terry, Stout & Kraus, LLP, Dep. Acct. No. 01-2135 (520.41003X00), and please credit any excess fees to such deposit account.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP



Gregory E. Montone
Reg. No. 28, 141

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